

FORM PTO-1449

INFORMATION DISCLOSURE CITATION

Atty Docket 0140/00272	Serial No. To be assigned
Applicant Arpan P. Mahorowala	
Filing Date 7/12/01 Herewith	Group Art Unit 1754 To be assigned

#2

5/5/902728

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-Class	Filing Date
AA						
AB						
AC						
AD						
AE						
AF						
AG						
AH						
AI						
AJ						
AK						

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub-Class	Trans-lation
AL						Yes No
AM						Yes No
AN						Yes No
AO						Yes No
AP						Yes No

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

WY	AR		Pattern Collapse in the Top Surface Imaging Process After Dry Development; Shigeyasu Mori, et al.; J. Vac. Sci. Technol. B 16(6); pp. 3744-3747 (Nov/Dec 1998)
	AS		
	AT		

Examiner <i>Minh Ha</i>	Date Considered <i>5/28/03</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 600. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant(s).